Form PTO 1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO. 243329US2		SERIAL NO.  New Application	
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				APPLICANT			
LIST OF	REFER	RENCES CITED BY APP	PLICANT	Kenichi KADOTA			
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XS	AO	2002-323924	11/08/02	Japan (with English Abstract)		<del> </del> .	X
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							per 1999, page 54
XS	AW	Laura PETERS, "Graphically Analyzing Yield Loss", SEMICONDUCTOR INTERNATIONAL, October 1999, page 54					
	AX						
	AY						
	AZ	Additional References sheet(s) attache					erences sheet(s) attached
Examiner De 18					Date Considered o 2/21/06		
*Examiner: I	nitiat if	reference is considered	, whether or n	ot citation is in conformance with MPER	609; Draw	line through	citation if not in
conformance	and n	ot considered. Include o	opy of this for	m with next communication to applican	t.		